

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Chih-Tsung Lin	§	Attorney Docket No.:	
		§		2003-0191 / 24061.60
		§		
Serial No.:	10/800,175	§	Examiner:	Hirl, Joseph P.
		§		
Filed:	March 12, 2004	§	Art Unit:	2129
		§		
For:	Knowledge Slicing and	§	Conf. No.:	8620
	Encapsulating Method in a	§		
	Semiconductor Manufacturing System	§		

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

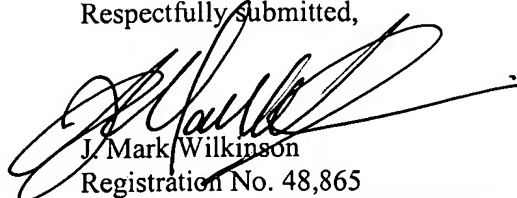
In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

Copies of only the foreign patent documents and non-patent literature listed on the enclosed modified Form PTO-1449 are attached.

The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed modified Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,


J. Mark Wilkinson
Registration No. 48,865


Date: 12-11-06
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R-145457_1.DOC

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 11, 2006.

Diane Sutton
Printed Name


Signature

In place of PTO-1449 Form	U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Application Number	10/800,175
		Filing Date	March 12, 2004
		Applicant(s)	Chih-Tsung Lin
		Art Unit	2129
		Examiner Name	Hirl, Joseph P.
SHEET 1 OF 2		Attorney Docket Number	2003-0191 / 24061.60

U. S. PATENT DOCUMENTS				
Examiner's Initials	Cite No.	Document Number	Publication Date <small>MM-DD-YYYY</small>	Name of Patentee or Applicant of Cited Document
		5,998,249	12/07/1999	Liaw et al.

FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign Patent Document <small>(Country Code - Number - Kind)</small>	Publication Date <small>MM-DD-YYYY</small>	Patentee or Applicant of Cited Document	Translation <small>Y/N</small>

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume, issue number(s), publisher, city/country where published
		YUSOF, NORAZAH, et al., "Domain-Expert Repository Management for Adaptive Hypermedia Learning System", IEEE International Conference on Advanced Learning Techniques, 2001, 2 pgs.
		YUSOF, NORAZAH, et al., "Domain-Expert Repository Management for Adaptive Hypermedia Learning System", IEEE IEEE International Conference on Advanced Learning Techniques, 34 pgs.
		HU, YU-SHU, et al., "Evaluating System Behavior Through Dynamic Master Logic Diagram (DMLD) Modeling", Elsevier Science Ltd., Reliability Engineering and System Safety 64, June 15, 1998, pp. 241-269.
		KECECI, NIHAL, et al., "Analyzing, Measuring & Assessing Software Quality Within A Logic-Based Graphical Framework", Qualita, March 22-23, 2001, 8 pgs.
		KECECI N. et al, "System-Software Interfaces for Safety-Related Digital I&C Systems", Center for Reliability Engineering MD USA, 6 pgs.

Examiner Signature	Date Considered
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

